

PATENT Customer No. 22,852 Attorney Docket No. 08137.0004-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assistant Commissioner for Patents Washington, DC 20231

Sir:

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## <u>AMENDMENT</u>

In reply to the Notice of Allowance dated January 30, 2002, please amend the application as follows:

## IN THE CLAIMS:

Please amend claims 1-5 and 12, as follows:

1. (Twice amended) A method of forming a thin film on a substrate in a reactor comprising a side having a shower head with a plurality of nozzles and a separate discharge nozzle, the method comprising:

positioning the substrate in the reactor;

heating the substrate to a predetermined temperature;



FINNEGAN HENDERSON FARABOW GARRETT& DUNNER LLP

1300 I Street, NW Washington, DC 20005 202.408.4000 Fax 202.408.4400 www.finnegan.com